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	TATEMENT E			First Named Inventor	Robert DWILINSKI	
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Sheet	1	of	2	Attorney Docket Number	204552035400	

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Examiner Cite No.1		Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	1.	US-6,153,010-A	11-28-2000	Kiyoku et al.			
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	3.	WO-98/47170-A	10-22-1998	Nichia Chemical Industries Ltd.	Translation of abstract and corresponds to US-6,153,010 listed above					
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*EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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	7.	Japanese Notification of Provision of Relevant Information on Prior Arts, mailed December 24,2008, directed to Japanese Patent Application No. 2004-558483; 14 pages	✓				
	8.	Kato, H. et al. (May 28, 1988)."MOVPE Growth of GaN on off-angle sapphire substrate", <i>IEICE Technical Report</i> . The Institute of Electronics, Information and Communication Engineers of Japan. Tokyo, Japan. 88(61):9 pages	✓				
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Signature		Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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